

 <p>INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p> <p>JUN 10 2005</p>				Docket Number (Optional) 15689.49.4		Application Number 10/673,940		
				Applicant(s) Takehiro Nakamura, et al.				
				Filing Date 9/29/2003		Group Art Unit 2631		
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
/K.K1/		5,497,395	3/5/1996	Jou	375	205	4/4/1994	
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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						<input checked="" type="checkbox"/> YES <input checked="" type="checkbox"/> NO		
/K.K./ ²		EP 0748074 A2	12/11/1996	Europe	H04J13	02	<input checked="" type="checkbox"/>	
/K.K./ ³		EP 0696113 A2	2/7/1996	Europe	H04B7	06	<input checked="" type="checkbox"/>	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
/K.K./ ⁴		Canadian Intellectual Property Office Application No.: 2,485,891 2005						
EXAMINER <i>/Kevin Kim/</i>				DATE CONSIDERED 9/26/05				
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